



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 21, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG819698292

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

13.17 x 8.83 x 5.53 mm

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

4.17 CARATS

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

IGI LG819698292

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG819698292

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS

13%

43.5%

43.6%

61%

62.6%

Slightly Thick To Thick (Faceted)

Pointed

Sample Image Used



LIGHT PERFORMANCE REPORT

Light Performance Grade: **Exceptional**



Structured Light Environment Representation

Moderate

High

Superior

Exceptional

Light Performance

Brightness

Fire

Contrast

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

4.17 CARATS

E

VS 1

62.6%

61%

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Pointed

EXCELLENT

EXCELLENT

NONE

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